

PORTABLE NON-CONTACT
3D OPTICAL PROFILER





## **ULTIMATE VERSATILITY**

Designed with Chromatic Light technology that measures physical wavelengths, the JR25 Profilometer offers the highest accuracy on any roughness, form, or material. Transparent or opaque.

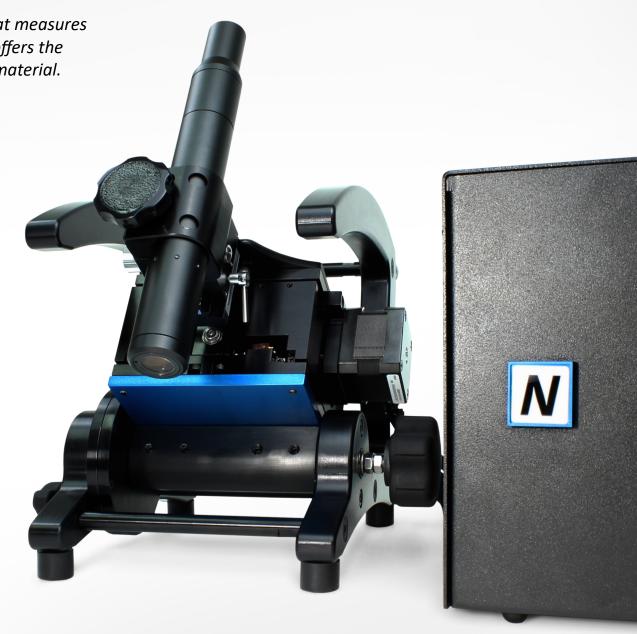
FIRST TRULY PORTABLE

3D NON-CONTACT PROFILOMETER

LAB-QUALITY RESULTS
IN THE FIELD

CHALLENGING ANGLES
NOW HASSLE-FREE

5.3 kg WEIGHT





X - Y STAGE TRAVEL

25 x 25 mm

**Z** AXIS

30 mm Manual

X - Y MAX SPEED

20 mm/s

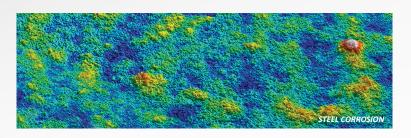
# THE POWER OF CHROMATIC LIGHT

**NANOVEA** Non-Contact Optical Profilers are the ideal upgrade from traditional contact stylus and laser profilometers.

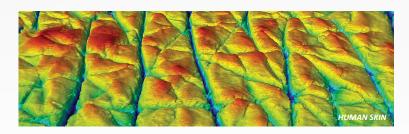


## 2D & 3D NON-CONTACT

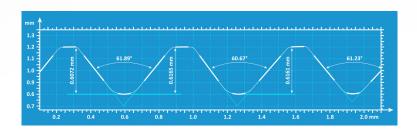
SURFACE MEASUREMENTS



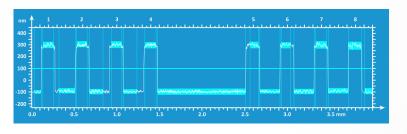
**ROUGHNESS & FINISH** 



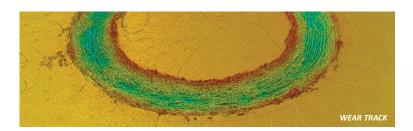
**TEXTURE & GRAIN** 



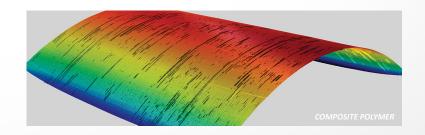
**GEOMETRY & SHAPE** 



STEP HEIGHT & THICKNESS



**VOLUME & AREA** 



**FLATNESS & WARPAGE** 

## ANY MATERIAL. TRANSPARENT, REFLECTIVE OR DARK

## STANDARD SENSOR SINGLE POINT

•	PS1	PS2	PS3	PS4	PS5	PS6
MAX HEIGHT RANGE	110 μm ——	300 μm ——	1.1 mm —	3.5 mm ——	10 mm ——	24 mm
WORKING DISTANCE	3.3 mm ——	10.8 mm —	12.2 mm —	16.5 mm —	26.6 mm —	20 mm
LATERAL X - Y ACCURACY	0.8 μm ——	1.7 μm ——	2.6 μm ——	4.6 μm ——	11.0 μm —	11.0 μm
HEIGHT REPEATABILITY*	1.9 nm ——	5.4 nm ——	15.8 nm ——	31.6 nm —	117.0 nm —	237.2 nm





up to 87° max surface angle

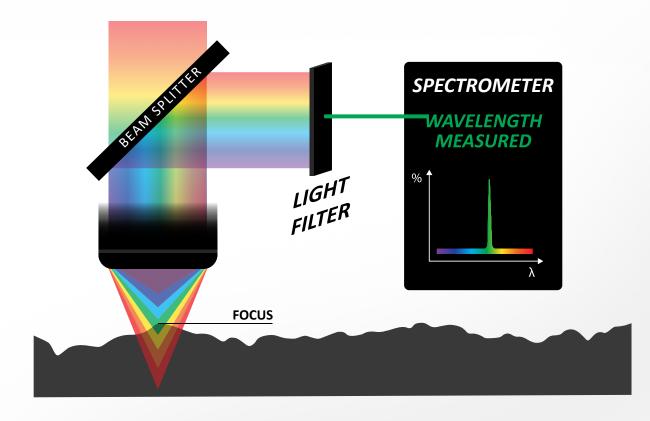
<sup>\*</sup> Fixed point measurement on glass. Ra average height variation for 1,200 points (100 samplings).

## HOW IT WORKS

Chromatic Light Technology works by using white light and a set of sphero-chromatic lenses to split the light into individual wavelengths, each with its unique vertical focal point or height. All wavelengths, with their corresponding heights, make up the height range measurement scale of a sensor.



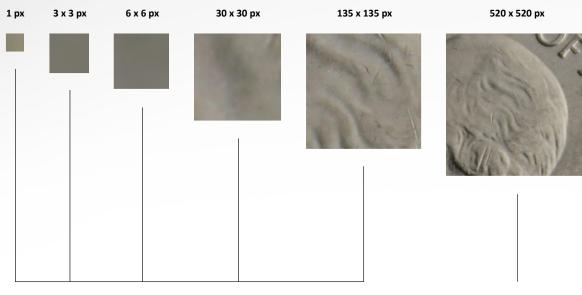
The spectrometer detects the wavelength with the highest intensity and processes its associated height measurement. During a full raster scan, this process takes only a fraction of a second and produces an accurate height map of the surface of interest.



NO COMPLEX ALGORITHMS • NO LEVELING REQUIRED • NO X-Y DATA STITCHING

## THE PROBLEM WITH OTHER TECHNIQUES

#### LATERAL RESOLUTION VS LATERAL ACCURACY



STATES OF THE ST

NOT ENOUGH DATA TO CALCULATE FOCUS
NO PRACTICAL USE

PIXEL SIZE RESOLUTION: 2nm

THE SMALLEST INCREMENT FOR ANY PRACTICAL USE

EFFECTIVE ACCURACY: 1040 nm

**THEM** 

To impress clients, companies often choose to define *Display Resolution* or *Camera Pixel Size* as lateral resolution. However, instruments that rely on camera pixel-based technology require complex algorithms to determine the focal point, which is problematic for analyzing complex surfaces.

**Chromatic Light** provides lateral **accuracy** which is determined by the physics and is directly related to the spot size of the chromatic light source of the optical sensor.

## LASER SCANNING CONFOCAL MICROSCOPE



## CHROMATIC LIGHT OPTICAL SENSOR



#### HEALTH HAZARD

Exposure to laser light reflectivity

#### SAFE WHITE LIGHT

No need for protective wear

#### INCONSISTENT LASER LIGHT WAVELENGTH

Inconsistencies in wavelength during scanning affect accuracy of results

#### **UNIFORM & BROAD WHITE LIGHT SPECTRUM**

Changes in wavelength are the data being collected

#### **DECEPTIVE 'DISPLAY RESOLUTION'**

Lateral & height accuracy are fixed by the objective lens making 'Display Resolution' insignificant

#### INDEPENDENT LATERAL & HEIGHT ACCURACY

Lateral & height accuracy can be mixed and matched to meet a broad range of scanning requirements

#### **COMPLEX ALGORITHMS**

Alpha blending algorithms stitch collected data layer by layer, grounding accuracy on complex calculations

#### **NO ALGORITHMS**

Physical wavelength reflected from the surface is measured directly for an accurate representative height map

#### STITCHING REQUIRED

Objective lenses have limited fixed fields of view Stitching of larger areas compromises accuracy of the scan

#### **NO STITCHING**

Data points are collected continuously providing the same level of accuracy for both small and large areas

#### 50x SLOWER

Data acquisition speed up to 7.9 KHz

#### **50x FASTER**

Data acquisition speed up to 384 KHz

### LASER MICROSCOPE

### **OPTICAL SENSOR**

#### LATERAL ACCURACY

For 50x objective (370 x 277  $\mu$ m)

- ± 2% of measuring value
- ± 2% x 370 μm
- ≈ 15 µm

w/ stitching algorithms >> 15 μm

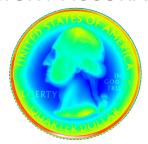
LIBERTY W

Step size:

= 5 µm

**3x BETTER LATERAL ACCURACY** 

#### **HEIGHT ACCURACY**



950 μm range

≈ 0.6 µm

**16x BETTER HEIGHT ACCURACY** 

#### $\approx 0.2 + L/100 \,\mu\text{m}$ $\approx 0.2 + 950/100 \,\mu\text{m}$

≈ 9.7 µm

#### **STITCHING REQUIRED**

# scans (25 x 25 mm) 25 000  $\mu$ m / 370  $\mu$ m x 25 000  $\mu$ m / 277  $\mu$ m 68 x 91

= 6188 scans

#### AREA TESTED



#### **NO STITCHING**

Consistent accuracy across any measurement size

1 SCAN

#### **TEST TIME**

6 sec per scan

- + 4 sec displacement & stitching
- = 10 sec/scan x 6188 scans
- = **61860 seconds** (≈ 17 hours)

Scan time (25 x 25 mm) = 29.6 seconds

2090x FASTER

## NANOVEA

# JR25 OPTICAL PROFILER

For pricing information, please contact sales@nanovea.com

Also available in other configurations



PORTABLE STANDARD



PORTABLE HIGH-SPEED



COMPACT STANDARD



MODULAR STANDARD



MODULAR LARGE AREA



